

Notice of References Cited	Application/Control No. 10/773,660		Applicant(s)/Patent Under Reexamination HO ET AL.	
	Examiner Julie E. Stein, Esq.		Art Unit 2688	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,597,913	07-2003	Natarajan, Kadathur S.	455/12.1
*	B	US-2002/0183039	12-2002	Padgett et al.	455/406
*	C	US-2004/0228349	11-2004	Vrzic et al.	370/395.4
*	D	US-2004/0162083	08-2004	Chen et al.	455/454
*	E	US-2004/0160914	08-2004	Sarkar, Sandip	370/329
*	F	US-2004/0160922	08-2004	Nanda et al.	370/335
*	G	US-2004/0162098	08-2004	Wei et al.	455/522
*	H	US-2005/0254465	11-2005	Lundby et al.	370/335
*	I	US-6,571,101	05-2003	Schulz, Egon	455/450
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	KR 2001056478 A	07-2001	Korea, Republic	KANG, G J	H04B 07/26
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.